Notice of References Cited Application/Control No. 10/724,718 Examiner Adam Levine Applicant(s)/Patent Under Reexamination LIN, CHING-CHI Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2001/0044758 A1	11-2001	Talib et al.	705/27
*	В	US-2001/0049636 A1	12-2001	Hudda et al.	705/26
*	С	US-2002/0026390 A1	02-2002	Ulenas et al.	705/27
*	D	US-2002/0029168 A1	03-2002	McConnell et al.	705/26
*	Е	US-2002/0055885 A1	05-2002	Kindo et al.	705/26
*	F	US-2002/0062258 A1	05-2002	Bailey et al.	705/26
*	G	US-2002/0082932 A1	06-2002	Chinnappan et al.	705/26
*	н	US-2002/0174022 A1	11-2002	Tenorio, Manoel	705/26
	-	US-			
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	s					
	Т					·

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	w	
	х	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.